

P/4303-34

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Valentin CHITIC et al.

Date: July 12, 2004

Serial No.: 10/780,334

Group Art Unit: 3635

Filed: February 17, 2004

Examiner: --

For: HOLLOW SECTION AND A PROCESS FOR ITS MANUFACTURE

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

S I R:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO 1449. A copy of each of the listed foreign documents is also enclosed.

The present Information Disclosure Statement is being submitted prior to issuance of a first Office Action on the merits in the present application.

The present invention defines a hollow section and a process for its manufacture which is not believed to be disclosed by the enclosed references.

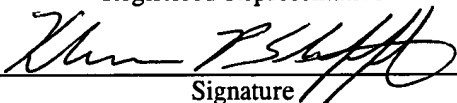
Each of the cited foreign references is accompanied by a U.S. equivalent or English-language Abstract.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee during the prosecution of this application is not paid, the Patent Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 12, 2004:

Klaus P. Stoffel

Name of applicant, assignee or
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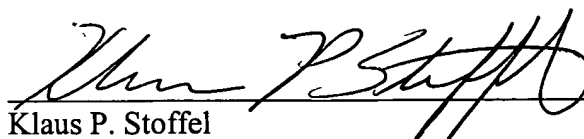


Signature
July 12, 2004

Date of Signature

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Respectfully submitted,



Klaus P. Stoffel

Registration No.: 31,668

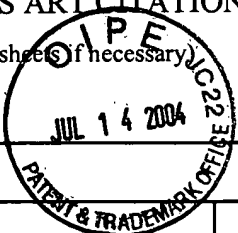
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| APPLICANT'S ART CITATION (Use several sheets if necessary) | | Application 10/780,334 | | OFGS File No. P/4303-34 | |
| | | Applicant CHITIC et al. | | | |
| | | Filing Date February 17, 2004 | | Group Art Unit 3635 | |



| U.S. PATENT DOCUMENTS | | | | | | |
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| | Document Number | Date MM-YYYY | Country | Class | Sub-class | Translation | |
| | | | | | | Yes | No |
| | CH 691-731 | 9/2001 | Switzerland (=US 6,003,930) | | | Abst. | |
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| Examiner | Date Considered |
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